

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Dao Min Zhou, et al)	Art Unit No.: 3762
)	
Application No: 10/655,772)	Examiner: Kahelin, Michael W.
)	
Filed: September 5, 2003)	Re: RESPONSE TO
)	RESTRICTION REQUIREMENT
)	
For: "Adherent Metal Oxide ...")	Our Ref: S232-USA
)	
)	
)	Date: November 28, 2007

RESPONSE TO RESTRICTION REQUIREMENT

Dear Examiner:

This paper is filed in response to the restriction requirement set forth in the Office Action dated October 26, 2007 a reply to which was initially due by November 26, 2007. Please consider the following remarks with respect to the subject application. All remarks herein are made without prejudice.

Remarks begin on page 2 of this paper.

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